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Contents

- v Symposium Committee
- ix Conference Committee

NOVEL IMAGING MODALITIES BASED ON FIELD ENGINEERING

12316 02 Photonic-hook enhanced microsphere-assisted label-free super-resolution imaging [12316-4]

12316 03 Biaxial AOTF transfer functions for spatial image filtering [12316-20]

SUPER-RESOLUTION IMAGING

12316 04 **Resolution enhanced imaging for endoscopy using diffractive optics** [12316-14]

TISSUE IMAGING

- 12316 05 Multispectral endoscopic imaging studies on the tissue components of gastrointestinal mucosa (Invited Paper) [12316-18]
- 12316 06 In-process OCT monitoring to control holographic laser processing [12316-21]

POSTER SESSION

12316 07	Super-resolution reconstruction of medical image via depth residual network [12316-28]
12316 08	OCT-measured retinal vasculature and intrinsic optical responses to transcorneal electrical stimulation [12316-33]
12316 09	Integrated multimodal and fluorescence imaging microscope based on LED illumination [12316-34]
12316 0A	Perceptual resolution improvements in far-field Fourier ptychography imaging [12316-35]
12316 OB	Portable imaging system based on dual-line fiber optic sensor array [12316-40]
1021/00	In a sing of evolutions and free charges in consistent durates by above medulated light because

12316 OC Imaging of excitons and free charges in semiconductors by phase modulated light beams [12316-44]

12316 OD	Efficient Fourier ptychographic microscopy with hybrid coherent and incoherent illumination [12316-46]
12316 OE	Zero-order suppression in slightly off-axis holography based on Fourier ptychographic reconstruction [12316-47]
12316 OF	Efficiency-optimized Fourier ptychographic microscopy based on spectrum overlap percentage analysis [12316-49]
12316 0G	Fast illumination parameter estimation of structured illumination microscopy [12316-50]

12316 0K Using time-correlated single-photon counting technique on SPAD sensors to enhance acquisition time and dynamic range [12316-52]

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